

Docket No.: 1028-0171P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Raymond BOISSEAU et al.

Application No.: 09/822,864

Confirmation No.: 7224

Filed: April 2, 2001

Art Unit: 2881

For: METHOD AND SYSTEM FOR  
CONTROLLING BEAM SCANNING IN AN  
ION IMPLANTATION DEVICE

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Examiner: K. T. Nguyen

**STATUS INQUIRY**

**MS: Petitions**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

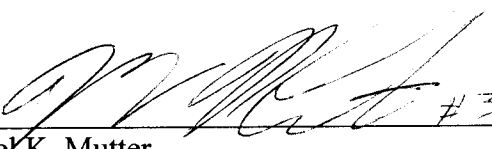
Sir:

A Petition to Withdraw the Holding of Abandonment was filed on February 17, 2004 in the above-identified application and resubmitted on June 23, 2004. Subsequently, a Status Inquiry was filed on February 18, 2005 and a Petition Inquiry was filed on August 1, 2005. To date, no reply to the Petition or any of the subsequent filings has been received from the U. S. Patent and Trademark.

Accordingly, it is respectfully requested that the undersigned be advised of the status of the Petition.

Dated: August 3, 2006

Respectfully submitted,

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